



Form PTO-1449	Document Number (Sequence)	Application Number
INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)	TSMC-02-1259	10/671,293
	Applicant	Chung-Hui Chen
	Filing Date	09/25/03
	Group Art Unit	2816

## U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILED DATE IF APPROPRIATE
JZ	5506457	4/9/96	Krauter et al.	307	129	4/7/95
JZ	6307250	10/23/01	Krauter et al.	257	532	4/1/96
JZ	5789964	8/4/98	Voldman	327	380	2/14/97

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

JZ	U.S. Patent App. Publication US 2002/0081832 A1 to
JZ	Bernstein et al., Pub. Date 6/27/02, "Intra-level
	Decoupling Capacitor, Method of Manufacture and
	Testing Circuit of the Same"

EXAMINER

Jeffrey Zweizig

DATE CONSIDERED

9/28/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.